Supporting Information

Enhanced Photovoltaic Performances of Graphene/Si Solar

Cells by Insertion of MoS₂ Thin Film

Yuka Tsuboi[†], Feijiu Wang[†], Daichi Kozawa[†], Kazuma Funahashi[‡],

Shinichiro Mouri[†], Yuhei Miyauchi[†], Taishi Takenobu[‡] and Kazunari Matsuda^{†*}

[†]Institute of Advanced Energy, Kyoto University, Gokasho, Uji, Kyoto 611-0011, Japan [‡]Department of Advanced Science and Engineering, Waseda University, Shinjuku-ku,

> *Tokyo 169-8555, Japan* *Email: matsuda@iae.kyoto-u.ac.jp

S1. MoS₂ film fabrication

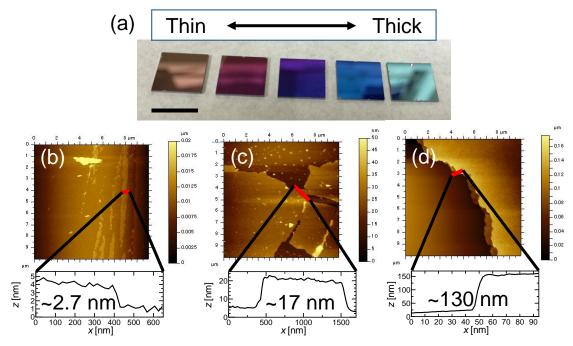


Figure S1. (a) Optical image of as-grown MoS₂ films with various layer thicknesses on SiO₂/Si substrates, as fabricated by the CVD method. The scale bar is 1 cm. The thickness of the MoS₂ films was controlled *via* the MoO₃ deposition time. We observed that MoS₂ film with a thickness of ~2/3 of the original MoO₃ film is fabricated by CVD process in the case of MoO₃ with an averaged thickness of 30 nm. The leftmost image is an SiO₂/Si substrate. (b)–(d) AFM image of an MoS₂ film. The height profiles are measured at the step edge between the MoS₂ film and the SiO₂/Si substrate. The thickness of the MoS₂ films was varied from 2.7 to 130 nm. For solar cells in Figure 3, we used films with ~17-nm thickness, as shown in (c).

S2. Process-flow of MoS₂ film transfer

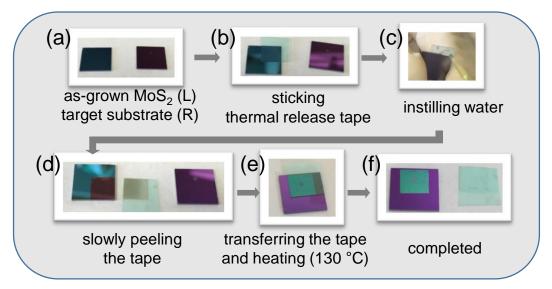
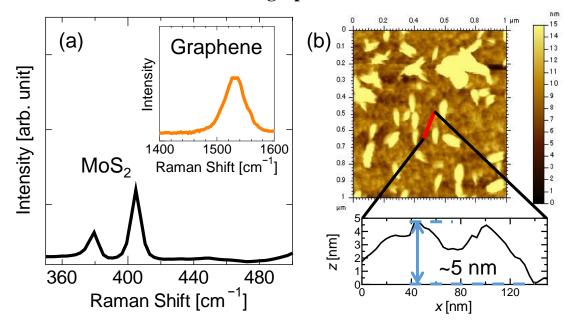


Figure S2. (a)–(f) The process-flow of as-grown MoS_2 film transfer. This method was conducted using thermal release tape (REVALPHA; No. 3195MS, Nitto Denko). The sticking MoS_2 film with the thermal release tape (left in (b)) was easily released by a drop of water, as shown in (c). After the tape with MoS_2 was transferred to the target substrate, the tape was removed by heating the substrate on a hotplate.



S3. Characterization of stacked graphene/MoS₂ film

Figure S3. (a) Raman spectrum of the vertical stacking of graphene/MoS₂. (b) AFM image of a stacked graphene/MoS₂ film and its height profile along the red line in the image. The surface roughness of the graphene/MoS₂ film decreases in comparison with that of the MoS₂ film (Figure 2(a)).

Cell Type	V _{oc} [V]	J _{SC} [mA/cm²]	FF	η [%]	R _s [Ω·cm²]
MLG/ <i>n</i> -Si	0.38	6.76	0.17	0.44	17
MLG/MoS ₂ / <i>n</i> -Si	0.41	13.1	0.25	1.35	30
BLG/MoS ₂ / <i>n</i> -Si	0.51	21.4	0.55	5.98	11
TLG/MoS ₂ / <i>n</i> -Si	0.54	28.2	0.53	8.02	8.8

S4. Photovoltaic parameters of graphene/MoS₂/*n*-Si solar cells

Table S1. Photovoltaic parameters of monolayer-graphene/*n*-Si and graphene/MoS₂/*n*-Si solar cells with monolayer-graphene (MLG), bilayer-graphene (BLG) and trilayer-graphene (TLG), as evaluated from experimentally obtained J-V curves. The open-circuit voltage V_{OC} , short-circuit current density J_{SC} , fill factor FF, photovoltaic efficiency η , and series resistance R_S are shown. Here, the R_S values were estimated from the slopes of the J-V curves.^{S1}

S5. Transmission spectra and sheet resistance of graphene

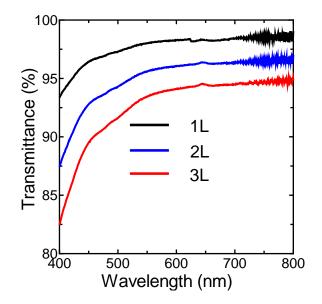


Figure S4. Transmission spectra of graphene films used in this study as a function of layer numbers.

Optical transmission spectra of graphene films used in this study are shown in Fig. S4. Sheet resistances of each sample were also measured by four-probe method. The sheet resistances drastically decreased from 41 k Ω /sq. in monolayer (1L), 4.9 k Ω /sq. in bilayers (2L), to 1.5 k Ω /sq. in trilayers (3L).

S5. The incident photon-to-current conversion efficiency (IPCE) spectrum of graphene/MoS₂/*n*-Si solar cells

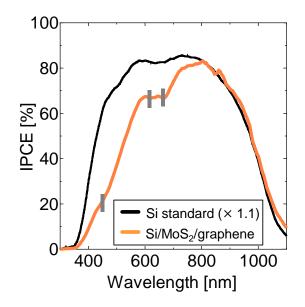


Figure S5. IPCE spectra of a trilayer-graphene/MoS₂/*n*-Si solar cell and a standard Si solar cell. The spectrum of the standard Si solar cell is normalized by the values at 800 nm. The dip structures were observed in the IPCE spectrum of graphene/MoS₂/*n*-Si in the shorter-wavelength region (400–700 nm). The positions of these dip structures are consistent with the absorption peaks of the MoS₂ film shown in Figure 2(b), which suggests that the generated carriers in the *n*-Si layer are the primary contributors to the photovoltaic current in the cell, whereas the MoS₂ functions as a shading layer at the point of light absorption.

S6. Carrier transport properties of an MoS₂ film, as measured by an electric double-layer transistor

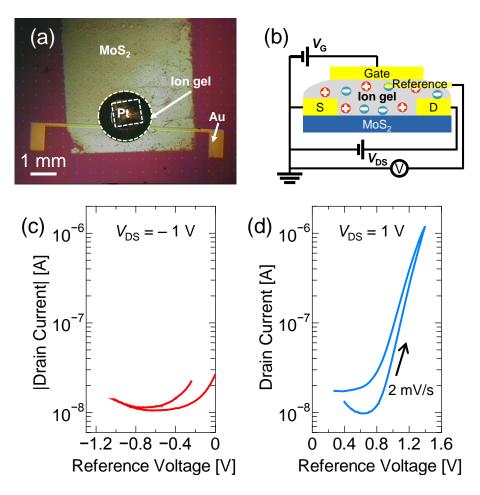


Figure S6. (a) Optical image of CVD-grown MoS_2 electric double-layer transistor and (b) A schematic illustration of the transistor, in which an ionic gel ([EMIM][TFSI] with PS-PMMA-PS) as a gate electrolyte, Pt as a top-gate electrode, and Ni/Au source and drain electrodes were used.^{S2} (c)(d) Transfer characteristics measured by changing the voltage of the Pt top-gate electrodes. Current resulting from electron transfer was confirmed (blue line), whereas current resulting from hole transfer was not (red line).

Reference

S1. Miao, X.; Tongay, S.; Petterson, M. K.; Berke, K.; Rinzler, A. G.; Appleton, B.
R.; Hebard, A. F., High Efficiency Graphene Solar Cells by Chemical Doping. *Nano Lett.* 2012, 12, 2745-2750.

S2. Pu, J.; Yomogida, Y.; Liu, K.-K.; Li, L.-J.; Iwasa, Y.; Takenobu, T., Highly Flexible MoS₂ Thin-Film Transistors with Ion Gel Dielectrics. *Nano Lett.* **2012**, 12, 4013-4017.